Schicht Nr. LAYER NUMBER	Schichtmaterial LAYER MATERIAL	Dicke Dicke der OF Schiebt	bicke der Or Schreht B	Dicke der Of Schicht C
7	n+ GaAs	500 nm	500 nm	500 nm
6	GaAs			10 nm
5	GaAs → Al _x Ga _{l-x} As	50 nm	50 nm	50 nm
4	GaAs		5 nm	10 nm
3	n _d GaAs	10 nm	5 nm	5 mm
2	n GaAs	1,6 µm	1 .6 μm	1 ₆ 6 μm
1	n+ GaAs	500 nm	500 nm	500 nm

Fig. 1

